

**Notice of References Cited**

Application/Control No.

10/596,415

Applicant(s)/Patent Under  
Reexamination  
VAN BOMMEL ET AL.

Examiner

ANDREW BOWMAN

Art Unit

1792

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**U.S. PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A US-2002/0098364	07-2002	Bernard et al.	428/447
*	B US-3,506,749	04-1970	WEISSMAN SAMUEL M	264/102
C	US-			
D	US-			
E	US-			
F	US-			
G	US-			
H	US-			
I	US-			
J	US-			
K	US-			
L	US-			
M	US-			

**FOREIGN PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
N					
O					
P					
Q					
R					
S					
T					

**NON-PATENT DOCUMENTS**

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
U	Pfeiffer et al, Polymer Stamps for Nanoimprinting, 2002, Microelectronic Engineering, Vol 61-62, pp. 393-398
V	Martin et al., Fabrication and Application of Hydrogel Stampers for Physisorptive Microcontact Printing, Langmuir, 2000, 16, pp. 9944-9946
W	
X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a))  
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